Form 1449*	Docket Number: PD-02-0421-B	Application Number: 10/700,089		
INFORMATION DISCLOSURE STATEMENT	Applicant: Erin H. Sibley et al.			
IN AN ADALICATION	Filing Date: November 3, 2003	Group Art Unit: (to be assigned)		

XAMETER	DOS MENT NO.	DATE	U.S. PATENT DOCUMENTS NAME	CLASS	SUBCLASS	FILING	DATE II
IMITIAL.	A						PRIATE
/J.R./	US2001/0039180	11/8/01	Sibley et al.				
/J.R./	US2001/0039662	11/8/01	Sibley		<u> </u>		
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		<u> </u>				YES	NO
J.R./	EP 0 491 068	6/24/92	ЕР			-	
I.R./	EP 1 152 614	11/7/01	EP				
J.R./	WO 01/97525	12/20/01	PCT				
.R./	WO 02/065772	8/22/02	PCT				
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	PATEN'	T ABSTRACT	TS OF JAPAN, Vol. 017, No. 29 3, English translation.	96 (P-1551), Jun	e 7, 1993 & JP	05 020272	(Sony
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EXAMINER: /Jivka Rabovianski/	DATE CONSIDERED:	08/30/2007						
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.								
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